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APPLICANTS

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** CONTINUING DATA *****

This application is a DIV of 09/838,216 04/20/2001 PAT R,E38,266
 which is a REI of 09/115,838 07/15/1998 PAT 6,071,766
 which is a DIV of 08/536,977 09/29/1995 PAT 5,789,284

MSL

** FOREIGN APPLICATIONS *****

JAPAN 6-259117 09/29/1994

MSL

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	JAPAN	DRAWING 9	CLAIMS 22	CLAIMS 4
Verified and Acknowledged	Examiner's Signature <i>MSL</i>	Initials			

ADDRESS

22204
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TITLE

Method for fabricating semiconductor thin film

		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 4.10 Filing Extension
FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	
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